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APPLICATION NO.	FI	LING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.		
09/695,873		10/26/2000	Lawrence E. Albertelli	FS-00496	FS-00496 2974		
30743	7590	06/21/2005		EXAM	EXAMINER		
WHITHAM	•	IS & CHRISTOFF S ROAD	NATNAEL,	NATNAEL, PAULOS M			
SUITE 340 RESTON, VA 20190				ART UNIT	PAPER NUMBER		
				2614			

DATE MAILED: 06/21/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)	_				
Office Action Summany		09/695,873	ALBERTELLI, LAWRENCE E.					
	Office Action Summary	Examiner	Art Unit					
		Paulos M. Natnael	2614					
Period fo	The MAILING DATE of this communication or Reply	appears on the cover sheet with t	he correspondence address					
THE - Exte after - If the - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR REMAILING DATE OF THIS COMMUNICATION mosions of time may be available under the provisions of 37 CFI SIX (6) MONTHS from the mailing date of this communication period for reply specified above is less than thirty (30) days, a period for reply is specified above, the maximum statutory period for reply within the set or extended period for reply will, by streply received by the Office later than three months after the med patent term adjustment. See 37 CFR 1.704(b).	ON. R 1.136(a). In no event, however, may a reply to the control of the control o	be timely filed ) days will be considered timely, from the mailing date of this communication. ONED (35 U.S.C. § 133).					
Status								
1)🖂	Responsive to communication(s) filed on <u>07 April 2005</u> .							
2a)⊠	This action is <b>FINAL</b> . 2b)□	This action is non-final.						
3)	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is							
	closed in accordance with the practice und	accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.						
Disposit	ion of Claims							
_	<ul> <li>4) Claim(s) 1-12 is/are pending in the application.</li> <li>4a) Of the above claim(s) is/are withdrawn from consideration.</li> </ul>							
· —	Claim(s) <u>1-5</u> is/are allowed.							
	Claim(s) <u>6-12</u> is/are rejected.							
/)□ 8)□	Claim(s) is/are objected to.	od/or olootion roominement						
0)	Claim(s) are subject to restriction ar	id/or election requirement.						
Applicat	ion Papers							
9)☐ The specification is objected to by the Examiner.								
10)	10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.							
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
11)	Replacement drawing sheet(s) including the color The oath or declaration is objected to by the		• • • • • • • • • • • • • • • • • • • •					
Priority (	under 35 U.S.C. § 119							
-	Acknowledgment is made of a claim for fore All b) Some * c) None of:  1. Certified copies of the priority documed to Certified copies of the priority documed to Cepies of the certified copies of the priority documed to Copies of the certified copies of the priority documed to Copies of the certified copies of the priority documed to Copies of the certified copies of the priority documed to Copies of the certified copies of the priority documed to Copies of the certified copies of the priority documed to Copies of the certified copies of the priority documed to Copies of the certified copies of the certified copies of the certified copies of the priority documed to Copies of the certified copie	nents have been received. Dents have been received in Appli Deriority documents have been rec	cation No					
* 0	application from the International Bu	` ''	ation at					
* \$	See the attached detailed Office action for a	list of the certified copies not rec	eived.					
Attachmen	t(s)							
	e of References Cited (PTO-892)	4) Interview Summ						
3) 🔲 Inform	e of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB r No(s)/Mail Date		all Date nal Patent Application (PTO-152)					

#### **DETAILED ACTION**

# Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claims **6** and **7** are again rejected under 35 U.S.C. 102(b) as being anticipated by Hibbs et al. U.S. 5,508,803.

Considering claim **6**, the claimed "plurality of sub-fields, respective sub-fields including a plurality of features, said plurality of features of respective sub-fields of said plurality of sub-fields having a progression of image feature size and pitch", is met by Fig.1, which shows a progression of size and pitch from left to right up to the center field 16 and on to the subfield 12, which has the smallest feature size and pitch. As to the claimed "... encompassing the spatial resolution of said imaging system, referred to an object plane of said imaging system", Hibbs discloses on col. 3, lines 66 to col. 4, line 17 that "The pitch is chosen in the Starikov exposure monitor to be below the resolution of a lithographic exposure tool used therewith, so the lines appear to blur upon imaging. The line-to-space ratio varies across exposure monitor 10, so that the net effect is that of a single, broad, diffuse line with linearly varying optical intensity on each side of the center 16... As the resolution of the exposure tool improves, the line size needed within

Art Unit: 2614

exposure monitor 10 becomes smaller, straining the ability of the mask fabrication tool to faithfully create the exposure monitor and the ability of the pattern verifier to verify the lines in the exposure monitor." [Emphasis added by examiner]

Considering claim 7, wherein said features include lines and spaces, is met by the lines and spaces in Figs. 1 and 2.

## Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims **8-12** are rejected under 35 U.S.C. 103(a) as being unpatentable over Hibbs, U.S. Pat. No. 5,917,987 in view of Bentley, U.S. 3,853,403.

Considering claim 8, further including indicia indicating a resolution corresponding to feature size of features in a sub field:

Regarding claim 8, Hibbs does not specifically disclose indicia to indicate resolution. However, imaging the indicia or numeral or legends to indicate a function, or to use numerical units on the screen or target image to indicate the value or range of a parameter is notoriously well known in the art. In this regard, Bentley discloses a

Page 4

compound optical-sensor system for visually observing and photo electrically sensing coded indicia, wherein the coded indicia are imaged on aperature of a mask. It would have been therefore obvious to the skilled in the art at the time the invention was made to modify the system of Hibbs by adding numerical units or indicia within the target image to indicate its resolution or other parameter corresponding to preferred range of values in order to make the inspection of the target image of fig.1 easier for an operator who would then be able to quickly compare and determine the resolution (or other parameters) of the target image by inspecting the numerical values included therein.

Considering claim 9, including indicia indicating a resolution corresponding to pitch of features in a sub field.

Regarding claims 9, see rejection of claim 8;

Considering claim 10 and 11, wherein said indicia is a human readable number:

Regarding claims 10 and 11, see rejection of claim 8.

Considering claim 12, including reference numbers corresponding to resolution of said imaging system and a further indicia.

Regarding claims 12, see rejection of claim 8.

Art Unit: 2614

# Response to Arguments

5. Applicant's arguments filed 4/7/05 in relation to claims 6-12 have been fully considered but they are not persuasive.

In response to applicant's arguments, the recitation "Moire fringes" in claim 6 has not been given patentable weight because the recitation occurs in the preamble. A preamble is generally not accorded any patentable weight where it merely recites the purpose of a process or the intended use of a structure, and where the body of the claim does not depend on the preamble for completeness but, instead, the process steps or structural limitations are able to stand alone. See *In re Hirao*, 535 F.2d 67, 190 USPQ 15 (CCPA 1976) and *Kropa v. Robie*, 187 F.2d 150, 152, 88 USPQ 478, 481 (CCPA 1951).

Please note Hibbs et al. discloses a method and apparatus for monitoring lithographic exposure. Hibbs et al clearly illustrates in fig. 1 varying feature size or line width and pitch. And, contrary to Applicant's assertion, column 3, line 59 does not disclose constant pitch, as Applicant asserts. Instead, the passage discloses that the center region has a width of .8 microns while the other regions have 0.4 microns. There is no constancy there. Specifically, Hibbs discloses a mask structure (fig.1), having different feature or size (line-width) and pitch, not a single feature as Applicant alleges. Hibbs does not disclose these line are the same feature. In fact, it is clear from Fig.1 that the stripes have different features and different pitch to the right and left of the center field 16. Hibbs also discloses that the pitch is chosen in the monitor to be below the resolution of a lithographic exposure tool used therewith. (col. 3, line 66 thru col. 4,

Page 6

line 2) In other words, the resolution of the tool is directly linked to the result or the parameters of the target. Therefore, the argument is not persuasive, because the resolution of the camera or imaging system and the resolution of the target displayed cannot be separated, the latter depends on the performance of the former."

Therefore, Hibbs et al clearly illustrates in Fig. 1 varying feature size/line width and pitch. Given a reasonably broad interpretation, the lines 12-16 are considered subfields. The subfield 16 has the widest feature size, while the subfields 12 (on both sides of exposure 10) have the smallest. The size of the pitch for 12 and space 14 is not same as the pitch for the next one. Center 16 again has widest pitch, therefore, it cannot be argued the pitch is constant.

As to the arguments against Bentley, examiner submits that Bentley discloses a compound optical-sensor system for visually observing and photo electrically sensing coded indicia, wherein the coded indicia are imaged on aperature of a mask. It would be obvious to the skilled in the art to modify the system of Hibbs by adding numerical units or indicia within the target image to indicate its resolution or other parameter corresponding to preferred range of values in order to make the inspection of the target image of fig.1 easier for an operator who would then be able to quickly compare and determine the resolution (or other parameters) of the target image by inspecting the numerical values included therein.

Hence, arguments are considered unpersuasive.

Application/Control Number: 09/695,873 Page 7

Art Unit: 2614

# Allowable Subject Matter

6. Claims **1-5** remain allowable over the prior art.

7. The following is a statement of reasons for the indication of allowable subject matter: the prior art fails to discloses a method of measuring resolution of an imaging system, the method comprising the following steps: imaging a target including a plurality of subfields, respective sub-fields of said plurality of subfields providing a progression of image feature size and pitch encompassing the spatial resolution of said imaging system, to produce a captured image, inspecting said captured image for presence or absence of Moire patterns in sub-fields of said captured image, and determining resolution of said imaging system from feature size and pitch in respective sub-fields inspected in said inspecting step, as in claim 1.

### Conclusion

8. **THIS ACTION IS MADE FINAL.** Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of

Art Unit: 2614

the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Paulos M. Natnael whose telephone number is (571) 272-7354. The examiner can normally be reached on 10:00am - 6:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John Miller can be reached on (571)272-7353. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Paulos M. Natnael Primary Examiner Art Unit 2614

June 19, 2005